



PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Hiroyuki NAGASAKA

Group Art Unit: 2882

Application No.: 10/589,962

Examiner: C. RIDDLE

Filed: August 18, 2006

Docket No.: 128675

For: EXPOSURE METHOD, EXPOSURE APPARATUS, EXPOSURE SYSTEM AND
DEVICE MANUFACTURING METHOD

AMENDMENT WITH RCE

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In reply to the August 16, 2010 Office Action, in view of the November 15, 2010
personal interview, and after entry of the attached Request for Continued Examination, please
consider the following:

Amendments to the Claims as reflected in the listing of claims; and

Remarks.